


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/777,173	KIYA ET AL.	
	Examiner	Art Unit	
	Lucy P. Chien	2871	

SEARCHED			
Class	Subclass	Date	Examiner
349	54	6/20/2005	LC
349	55	6/20/2005	LC
349	192	6/20/2005	LC

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
349/54,55,192.ccls. and irradiation near laser adj beam	6/20/2005	LC